ACKNOWLEDGEMENT RECEIPT

Electronic Version 1.1

Stylesheet Version v1.1.1

Title of Invention

REMOVAL OF MEMS SACRIFICIAL LAYERS USING SUPERCRITICAL FLUID/CHEMICAL FORMULATIONS

Submision Type: Information Disclosure

Statement

Application Number:

10/724791

EFS ID: 103834

Server Response:

Confirmation Code	Message
	Submission was successfully submitted - Even if Informational or Warning Messages appear below, please do not resubmit this application
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First Named Applicant: Michael Korzenski
Attorney Docket Number: 020732-100.686

Timestamp: 2006-02-22 14:49:40 EDT

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File Listing:

Doc. Name	File Name	Size (Bytes)	Date
			Produced
			(yyyymmdd)
us-ids	ATMI100-usidst.xml	1201	2006-02-22
us-ids	us-ids.dtd	7763	2006-02-22
us-ids	us-ids.xsl	12026	2006-02-22
us-fee-sheet	ATMI100-usfees.xml	1647	2006-02-22
us-fee-sheet	us-fee-sheet.xsl	25930	2006-02-22
us-fee-sheet	us-fee-sheet.dtd	11968	2006-02-22
package-data	ATMI100-pkda.xml	2267	2006-02-22
package-data	package-data.dtd	27025	2006-02-22
package-data	us-package-data.xsl	19263	2006-02-22
	Total files size	109090	

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